

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: METHOD AND APPARATUS FOR TREATING SURFACE OF SUBSTRATE PLATE
Attorney Docket Number:: 216202US3
Total Drawing Sheets:: 9

INVENTOR INFORMATION

Inventor Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Kenya
Family Name:: WADA
City of Residence:: Naka-gun
State or Prov. of Residence:: Kanagawa-ken
Country of Residence:: Japan
Street:: 1-96-4, Yurigaoka, Ninomiya-machi
City:: Naka-gun
State or Province:: Kanagawa-ken
Country:: Japan

Inventor Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Kazuto
Family Name:: KINOSHITA
City of Residence:: Naka-gun
State or Prov. of Residence:: Kanagawa-ken
Country of Residence:: Japan
Street:: 617-1, Ninomiya, Ninomiya-machi
City:: Naka-gun
State or Province:: Kanagawa-ken
Country:: Japan

Inventor Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Kazuhiko
Family Name:: GOMMORI
City of Residence:: Naka-gun
State or Prov. of Residence:: Kanagawa-ken
Country of Residence:: Japan
Street:: 402-12, Ninomiya, Ninomiya-machi
City:: Naka-gun
State or Province:: Kanagawa-ken
Country:: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

FOREIGN PRIORITY INFORMATION

Country:: Japan
Application Number:: 2001-182679
Filing Date:: 06/18/01

ASSIGNMENT INFORMATION

Assignee Name:: Hitachi Electronics Engineering Co., Ltd.
Street:: 16-3, Higashi 3-chome,
City:: Tokyo
Country:: Japan

USPTO Patent Application Disclosure System